

<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> ( Not for submission under 37 CFR 1.99)	Application Number		10799481
	Filing Date		2004-03-11
	First Named Inventor	Hiroshi OKAGAWA	
	Art Unit	<del>2016</del> 2416	
	Examiner Name	Ben H. LIU	
Attorney Docket Number		FUJO 21.012	

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